

(Use several sheets if necessary)

Application Number

Filing Date

Herewith

Group Art Unit

JJC625 U.S. PTO
 09/502078
 02/10/00

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MDP	AB	"EPIC CSP Assembly and Reliability Methods," James E. Kohl et al., originally published in the Proceedings of CS198, Santa Clara, California, May 1998.
MDP	AC	"Low Cost Chip Scale Packaging and Interconnect Technology," James E. Kohl, et al., originally published in the Proceedings of the Surface Mount International Conference, San Jose, California, September 1997.

EXAMINER

DATE CONSIDERED

EXAMINER/ Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.